

# Pareto Optimal Spectrally Selective Emitters for Thermophotovoltaics via Weak Absorber Critical Coupling

*Nari Jeon<sup>1</sup>, Jonathan J. Hernandez<sup>2,4</sup>, Daniel Rosenmann<sup>3</sup>, Stephen K. Gray<sup>3</sup>, Alex B. F. Martinson<sup>1,\*</sup>, Jonathan J. Foley IV<sup>4,\*</sup>*

<sup>1</sup>Materials Science Division, Argonne National Laboratory, Argonne, Illinois, 60439, USA

<sup>2</sup>Union County College, 1033 Springfield Avenue, Cranford, New Jersey, 07016, USA

<sup>3</sup>Nanoscience and Technology Division, Argonne National Laboratory, Argonne, Illinois, 60439, USA

<sup>4</sup>Department of Chemistry, William Paterson University, 300 Pompton Road, Wayne, New Jersey, 07470, USA

## KEYWORDS

Thermophotovoltaics, thermal emission, selective emitter, atomic layer deposition, critical coupling, Pareto optimality

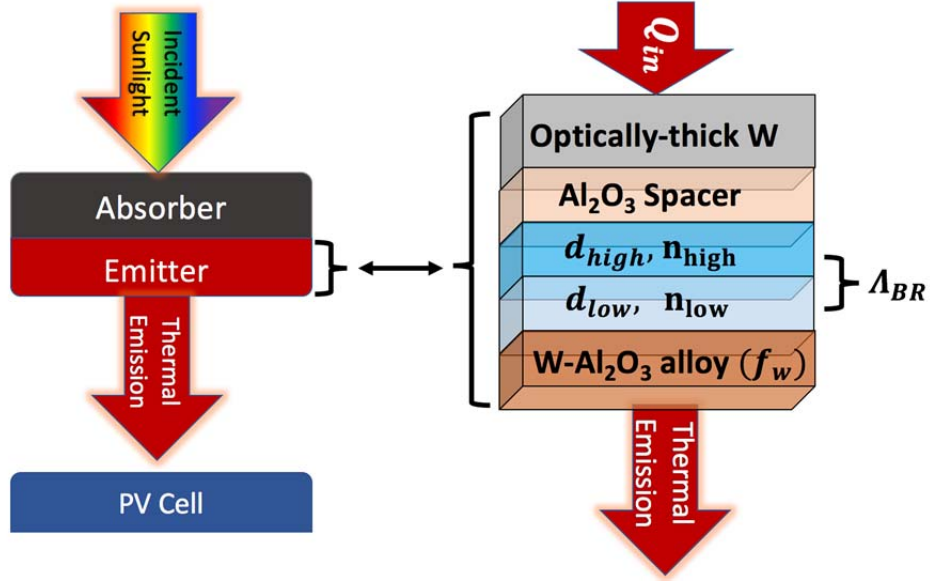
## ABSTRACT

Tailoring the emission spectra of a thermophotovoltaic emitter away from that of a blackbody has the potential to minimize transmission and thermalization loss in a photovoltaic receiver. Selective thermophotovoltaic emitters could lead to solar energy conversion with efficiency greater than the Shockley-Queisser limit and could facilitate the generation of useful energy from

waste heat. We introduce a new design to radically tune thermal emission that leverages the interplay between two resonant phenomena in a simple planar structure – absorption in weakly-absorbing thin films and reflection in multi-layer dielectric stacks. We employ a virtual screening approach based on Pareto optimality to identify a small number of promising structures for a selective thermal emitter from a search space of millions, several of which approach the ideal values of a step-function selective thermal emitter. One of the more simple and optimal of these structures is experimentally fabricated and evaluated, which includes a weakly-absorbing alloy with tailored optical properties fabricated by atomic layer deposition. The versatility of the design and fabrication approach result in an emitter with excellent spectral density ( $0.8 \text{ W/cm}^2 \text{ sr}$ ) and spectral efficiency (46.8%) at 1373 K. Future experimental challenges to a more accurate realization of the optimal structures calculated are also considered, including a weak absorber with more ideal optical constants and even greater thermal stability.

## Introduction

The broad range of solar photon energies (0.5 – 4.1 eV) fundamentally limits single gap solar photovoltaics (PV) efficiency, owing largely to photons with energies below the bandgap that do not contribute to photocurrent and photons with energies above the bandgap, which result in losses from a variety of dissipation mechanisms including thermalization.<sup>1-7</sup> The potential benefit of “reshaping” the solar spectrum to minimize these losses in a target PV cell is a central idea behind solar thermophotovoltaics (STPVs).<sup>3, 6, 8</sup> In a STPV device, concentrated sunlight is incident upon an absorber that is in thermal contact with an emitter. The thermal radiation of this hot emitter may be tailored to match the bandgap of a PV cell, see **Figure 1**, which allows for STPVs with a significantly greater fundamental limit (85 %) than traditional single junction PVs (33%).<sup>3</sup> More generally, thermophotovoltaics (TPVs) utilize the same selective emitter paired with a PV cell, but the heat source may come from a variety of non-solar sources, including waste heat generated by engines and reactors. Thus, TPV and STPV devices or, for short, S(TPV) devices, could constitute a versatile clean energy strategy.



**Figure 1** Schematic of a STPV system (left) and representative illustration of the novel emitter design (right). Structural parameters that are varied in our virtual screening approach include the Bragg reflector (BR) dielectric layer thicknesses,  $d_{high}$  and  $d_{low}$ , of  $n_{high}$  and  $n_{low}$  refractive indices, the number of such pair layers,  $\Lambda_{BR}$ , and the W volume fraction of the W- $\text{Al}_2\text{O}_3$  alloy,  $f_w$ . Heat ( $Q_{in}$ ) flows from the absorber to the emitter via an optically-thick W layer, and spectrally-tailored thermal emission radiates from the W- $\text{Al}_2\text{O}_3$  side. Here the  $n_{high}$  and  $n_{low}$  are taken to be characteristic of  $\text{TiO}_2$  and  $\text{SiO}_2$ , respectively.

However, it remains the case that (S)TPVs are not yet a significant players in the clean energy market. Experimentally-realized efficiencies of STPV devices are currently far below the Shockley-Queisser limit.<sup>3, 9-12</sup> The selective thermal emitter is a critical component for (S)TPV devices which we characterize with two figures-of-merit. The useful power density,  $P$ , is the flux of photons emitted with energies at or above the PV's bandgap,  $\dot{N}_{\lambda \leq \lambda_{bg}}$ , multiplied by the bandgap energy,  $E_{bg}$ :

$$P = E_{bg} \cdot \dot{N}_{\lambda \leq \lambda_{bg}} \quad , \quad (1)$$

where the wavelength associated with the bandgap is  $\lambda_{bg} = hc/E_{bg}$ , with  $h$  being Planck's constant and  $c$  being the speed of light. The photon flux, in turn, depends on the temperature and spectral properties of the emitter,

$$\dot{N}_{\lambda \leq \lambda_{bg}} = \int_0^{\lambda_{bg}} \frac{\lambda}{hc} \rho(\lambda, T) \epsilon(\lambda) d\lambda \quad , \quad (2)$$

where  $\rho(\lambda, T)$  is the blackbody spectral density and  $\epsilon(\lambda)$  is the emissivity spectrum of the emitter. Assuming the emitter structure is at thermal equilibrium,  $\epsilon(\lambda)$  is taken to be the absorption spectrum of the emitter (Kirchoff's law).<sup>13</sup> Therefore, the amount of useful power,

(insofar as a particular PV cell is concerned) generated per unit area of the emitter surface can be rewritten in a manner that permits straightforward computation once the temperature and emissivity are known<sup>14</sup>:

$$P = \int_0^{\lambda_{bg}} \frac{\lambda}{\lambda_{bg}} \rho(\lambda, T) \epsilon(\lambda) d\lambda. \quad (3)$$

The  $\lambda/\lambda_{bg}$  factor captures the disadvantage of photons with energies greater than the bandgap energy (i.e.,  $\lambda < \lambda_{bg}$ ) since these photons will not be as efficiently used as those at exactly the bandgap energy. In this simple view, the spectral conversion efficiency ( $\eta_s$ )<sup>14</sup> of the emitter/PV pair is then given by dividing the useful power density ( $P$ ) by the total emitted power density,  $P_{inc}$ :

$$\eta_s = \frac{P}{P_{inc}} = \frac{\int_0^{\lambda_{bg}} \frac{\lambda}{\lambda_{bg}} \rho(\lambda, T) \epsilon(\lambda) d\lambda}{\int_0^{\infty} \rho(\lambda, T) \epsilon(\lambda) d\lambda}. \quad (4)$$

Both of these figures of merit play important roles in the overall efficiency of the (S)TPV device. A high  $\eta_s$  is important for minimizing thermalization losses, while a large  $P$  is important for minimizing efficiency losses in the PV cell due to loss of open circuit voltage. A more detailed discussion of these considerations can be found in the supporting information, as well as in Ref. [6, 15].

The emissivity,  $\epsilon(\lambda)$ , is a key quantity in determining both  $\eta_s$  and  $P$  for a given candidate emitter structure. For example, if  $\epsilon(\lambda)$  is a delta function at  $\lambda = \lambda_{bg}$ , then the emitter has perfect spectral efficiency ( $\eta_s = 1$ ) but low  $P$ . Alternatively, if the emissivity has the form of a step function ( $\epsilon(\lambda) = 1$  for  $\lambda \leq \lambda_{bg}$  and  $\epsilon(\lambda) = 0$  otherwise), then  $P$  is maximized, although  $\eta_s$  will be less than unity. (A blackbody emitter is one that has  $\epsilon(\lambda) = 1$  for all  $\lambda$ , and will have the same  $P$  as the step-function case but will have a lower  $\eta_s$  due to a larger  $P_{inc}$  - see Eq. 4.) Optimal S(TPV) emitters will have thermal emission profiles between the two ideal limits of a step-function and a delta function.

From the above considerations, we see that the design of selective emitters for (S)TPV applications requires achieving large values of two conflicting objectives, the useful power density,  $P$ , and the spectral efficiency,  $\eta_s$ . That is,  $P$  may increase at the expense of  $\eta_s$  increasing and vice versa. Pareto optimality is a useful concept for considering such competing objectives.<sup>15-18</sup> In this context, a Pareto optimal emitter structure is one with a  $P$  value that

cannot be increased (by variation of structural parameters) without decreasing  $\eta_s$  and vice versa. There can be many such Pareto optimal structures that form a curve or “Pareto front” in a relevant portion of the  $\eta_s$ - $P$  space. A decision beyond the simple trade-off must then later be made regarding the acceptable magnitudes of the two objectives as to which structure along a Pareto front is best for an application at hand. Pareto analysis has recently been used in other virtual design approaches, including the design of solar absorbers<sup>15</sup> and the design of molecules for efficient organic light emitting diodes<sup>16</sup>.

A variety of planar and nanostructures have previously been explored in search of high-performance selective emitters, several of which are summarized in **Table 1**.<sup>19</sup> The greatest  $\eta_s$  simulated to date is ~59% from a W photonic crystal (2D square array of cylindrical holes) fabricated via interferometric lithography using a trilayer resist process.<sup>20</sup> Among experimental studies of high temperature emission, the highest reported  $\eta_s$  is ~35% from a HfO<sub>2</sub>-coated Ta photonic crystal.<sup>21</sup> A more detailed comparison would also consider steep emittance angles – conditions under which the  $P$  and/or  $\eta_s$  performance of many designs quickly declines. Furthermore, the metrics for many of the reported emitters are based on simulations alone or on room temperature reflectance measurements, leaving much room for evaluation of  $P$  and  $\eta_s$  at useful operating temperatures (>1200 K). As shown in **Table 1**, we identify simple simulated structures with record  $\eta_s$  while maintaining similar or superior  $P$ . Likewise, the structures fabricated herein show record  $\eta_s$  while maintaining a  $P$  similar to previous experimental reports.

The structures under investigation in this work can be classified as  $L$ -layer planar structures with variations only along the  $z$ -axis and that are isotropic along the  $x$  – and  $y$  –axes, where  $L$  is the number of layers. The base layer (in thermal contact with the hypothetical absorber in **Figure 1**) consists of an optically-thick tungsten (W) substrate. This layer is separated from a Bragg reflector (with alternating SiO<sub>2</sub> and TiO<sub>2</sub> layers) by a thin alumina layer that aids adhesion while having negligible impact on the optical properties; we note that the negligible impact of such adhesion layers cannot be universally assumed<sup>22</sup>, and we will pursue fabrication strategies to avoid them in the future.

The Bragg reflector supports an alloy of tungsten in alumina with optical properties that are tunable with volume fraction.<sup>23</sup> Spectrally-tailored thermal radiation is designed to be emitted from the surface of the thin alloy layer and collected by a InGaAsSb PV cell. The interplay between the Bragg reflector and the alloy layer plays a critical role in defining the emissivity of the structure, and by extension, its  $\eta_s$  and  $P$  figures-of-merit. Under certain conditions, absorption resonances in the alloy layer may be critically coupled to the reflection resonances of the Bragg reflector, leading to strong selective thermal emission profiles of the composite

structure. Similar critical coupling mechanisms have been utilized, for example, to realize extraordinary absorption in graphene monolayers/photonic crystal composites,<sup>24-25</sup> as well as enhanced absorption<sup>26</sup> and Forster Resonance Energy Transfer

	$P_{\perp}$ [W/cm <sup>2</sup> sr]	$\eta_s$ [%]	PV (bandgap)	T [K]	Method
<b>W Photonic crystal</b> <sup>20</sup>	1.9	58.9	InGaAsSb (0.55eV)	1500	Simulation
<b>VO<sub>2</sub> photonic crystal</b> <sup>12</sup>	1.4	40.4	In <sub>0.69</sub> Ga <sub>0.31</sub> As (0.62eV)	1500	Simulation
<b>W graded index</b> <sup>27</sup>	3.0	56.2	GaSb (0.73 eV)	1750	Simulation
<b>This work (theory)</b>	0.6	64.5	InGaAsSb (0.55 eV)	1273	Simulation
<b>This work (theory)</b>	1.7	66.5	InGaAsSb (0.55 eV)	1500	Simulation
<b>This work (theory)</b>	3.3	66.4	InGaAsSb (0.55 eV)	1700	Simulation
<b>Ta photonic crystal</b> <sup>11</sup>	1.8	48.6	InGaAsSb (0.54 eV)	1500	Reflection @ RT
<b>W/HfO<sub>2</sub> multilayer</b> <sup>28</sup>	0.3	44.0	InGaAsSb (0.55 eV)	1273	Reflection @ RT
<b>Ta photonic crystal</b> <sup>21</sup>	0.5	34.5	InGaAs (0.62 eV)	1255	Emission @ 1255 K
<b>Si/SiO<sub>2</sub>/Pt photonic crystal</b> <sup>29</sup>	0.1	19.3	InGaAsSb (0.55 eV)	939	Emission @ 939 K
<b>W/HfO<sub>2</sub> multilayer</b> <sup>28</sup>	0.6	33.5	InGaAsSb (0.55 eV)	1273	Emission @ 1273 K
<b>This work (experiment)</b>	0.5	45.4	InGaAsSb (0.55 eV)	1273	Emission @ 1273 K
<b>This work (experiment)</b>	0.8	46.8	InGaAsSb (0.55 eV)	1373	Emission @ 1373 K

**Table 1.** Calculated and experimental performance of selective emitters considering only normal emission per convention. See Supporting Information Eq. (S6) for the definition of  $P_{\perp}$ . The literature values of selective emittance in Table 1 may differ from some reports in which the figure of merit does not explicitly account for the disadvantage of photons with energies greater than the bandgap.

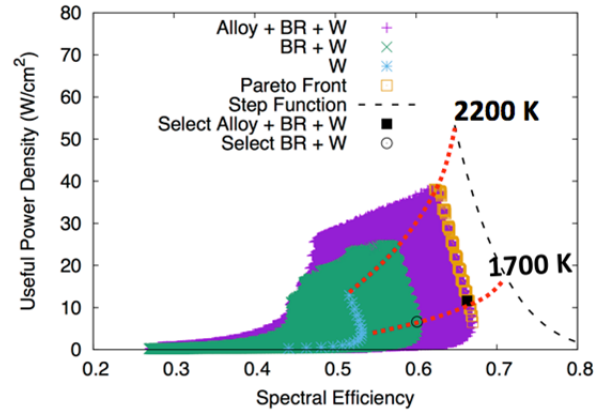
(FRET)<sup>30</sup> in thin films composed of J-aggregates critically coupled to a Bragg Reflector. In our design, the conditions for critical coupling between the alloy layer and the Bragg reflector are as follows: the frequency of resonant absorption in the alloy layer is equal to the frequency of resonant reflection in the Bragg reflector, and the absorption rate of the alloy layer is equal to the

leakage rate of the Bragg reflector. The resonance frequencies and leakage rates of Bragg reflectors are tuned through geometry and choice of material. Similarly, the absorption frequency and rate in metal-in-dielectric alloys can be tuned through choice of materials and volume fraction of the alloy. The tungsten-alumina alloys simulated here exhibit a weak resonant absorption in the near-IR ( $\sim 1500$  nm), which is ideal for (S)TPV applications.

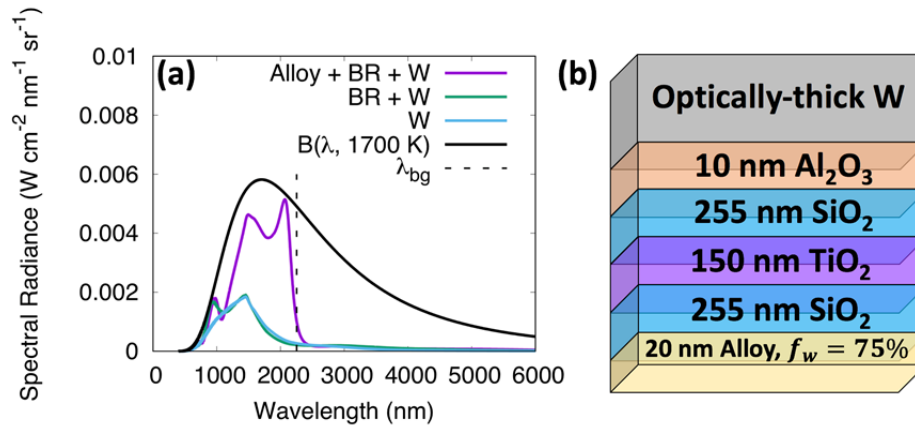
Our virtual screening approach utilizes multi-layer Fresnel theory calculations via the transfer matrix equation<sup>31</sup> to determine the absorbance (and thus emissivity) for  $\approx 3$  million candidate structures. The figures of merit  $P$  and  $\eta_s$  when paired with a common low-bandgap PV, InGaAsSb ( $\lambda_{bg} = 2254$  nm,  $E_{bg} = 0.55$  eV) were determined and Pareto optimal points were identified. We further define a metric that quantifies the degree of critical coupling in our structures (Equation 6 below) and show that high degrees of critical coupling are correlated with Pareto optimality. One Pareto optimal structure exhibits excellent computed performance:  $\eta_s = 66\%$  and  $P_{\perp} = 3.3$  W/cm<sup>2</sup> sr at 1700K (see SI Eq. S6 for the definition of  $P_{\perp}$ ). At 1500K the same structure is also predicted to exhibit record  $\eta_s$ , with  $P$  also among the highest reported to date (see Table 1). A related Pareto optimal structure with excellent  $\eta_s$  (60%) and even greater  $P_{\perp}$  (3.9 W/cm<sup>2</sup> sr) at 1700K was targeted for experimental fabrication with and without the weak absorber and subsequently characterized at high temperature to identify potential limitations in experimental feasibility and stability. Although the weak absorber fabricated was found to have non-ideal optical properties and limited thermal stability, the performance after accounting for non-idealities in each component layer was found to resemble theoretical predictions. The spectral emissivity of a Pareto optimal structure without alloy at 1373K exhibited record  $\eta_s = 46.8\%$  and a respectable  $P_{\perp} = 0.8$  W/cm<sup>2</sup> sr.

## Results

The planar structures computationally screened include optically-thick tungsten only (denoted ‘W’), variable Bragg reflectors only on an optically-thick tungsten substrate (denoted ‘BR + W’), and variable W/Alumina alloys with variable Bragg reflectors on an optically-thick tungsten substrate (denoted ‘Alloy + BR + W’), see **Figure 1**. It can be seen in **Figure 2** that in each case, the additional degrees of freedom added by the subsequent structures significantly improves the optimal  $\eta_s$  and  $P$  values that are possible. As such, the Pareto front for the entire solution space is found within the ‘Alloy + BR + W’ structures. One select Pareto optimal structure and an analogous structure without alloy are examined in more detail below (denoted ‘Select Alloy + BR + W’ and ‘Select BR + W’).



**Figure 2.** Comparison of possible values for useful power density and spectral efficiency for a variety of planar structures at temperatures between 1200K and 2200K when  $\lambda_{BG} = 2254$  nm. The orange squares demark the Pareto front. The red-dashed lines intersect solutions at select temperatures (1700 K and 2200 K). An idealized emitter with step-function emissivity is also plotted for comparison. The simple Pareto optimal structure (and analogous structure without alloy) selected for further examination has a  $\Lambda_{BR} = 1.5$  Bragg reflector, **Figure 3**.



**Figure 3.** (a) Theoretical normal thermal emission spectrum of selected Pareto-optimal structure with and without 20-nm thick W-Al<sub>2</sub>O<sub>3</sub> alloy ( $f_w = 75\%$ ) weak absorber, compared to a W-only and blackbody emitter at 1700 K. Alloy + BR + W structure is predicted to have  $\eta_s = 66\%$  and  $P_{\perp} = 3.3 \text{ W cm}^{-2} \text{ sr}^{-1}$ . A dashed line illustrates the  $\lambda_{bg} = 2254$  of the hypothetical energy-receiving PV. (b) Schematic of a simple Pareto optimal structure selected for further examination.

A tungsten substrate with optical constants from the literature is seen to be an advantageous base



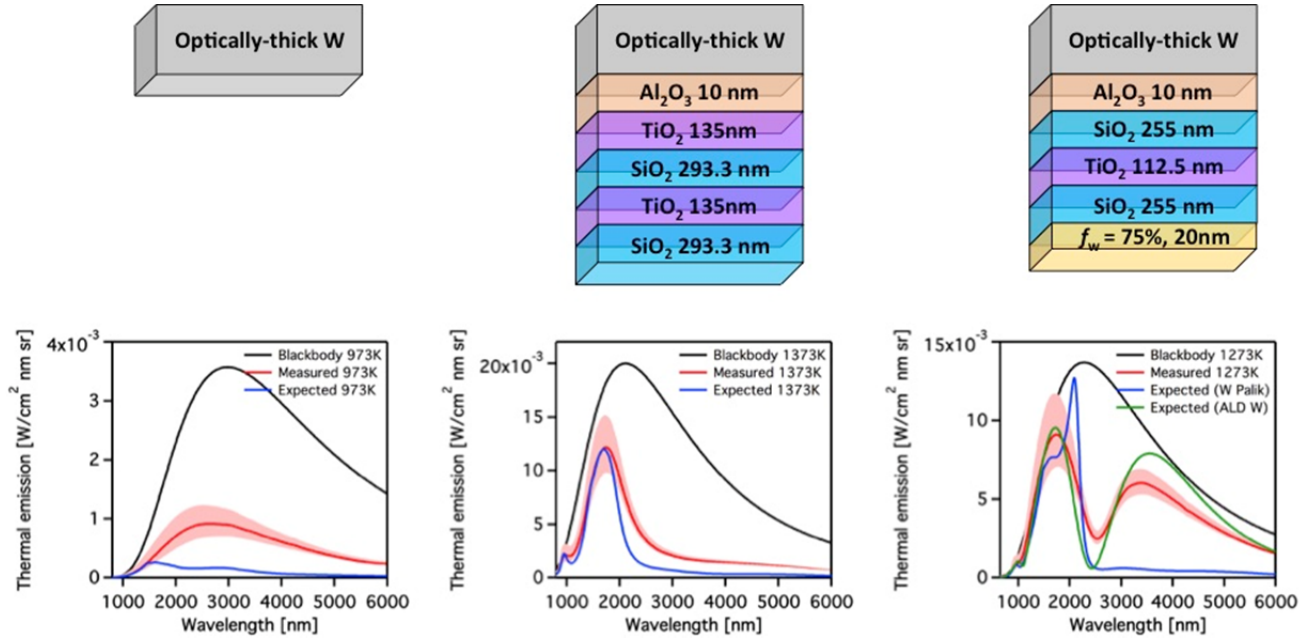
layer as its emissivity is already weighted heavily below the desired bandgap. The addition of the Bragg reflector in this case has only a minor impact on the short wavelength emissivity. However, as shown in **Figure 4**, some Bragg reflectors alone can strongly shape the emissivity and substantially improve  $P$  and  $\eta_s$  compared to bare tungsten. A striking calculated increase in  $P$  upon addition of the alloy can be understood from the emission spectra in **Figure 3**, which predicts emission with spectral radiance nearly equal to that of the black body limit ( $\epsilon(\lambda) = 1$ ) just below the PV bandgap. The peak around 1500 nm is also strongly enhanced. The virtual screening algorithm we apply assumes that the emissivity is angle-independent and that the emitted power density decreases as  $\cos(\theta)$  where  $\theta$  is the emission angle with respect to the normal; a more detailed discussion of angular dependence can be found in the Supporting Information. Under the  $\cos(\theta)$  assumption for the angular dependence of the thermal emission, the target structure is calculated to exhibit  $\eta_s$  and  $P$  of 66 % and 10.6 W/cm<sup>2</sup>, respectively at 1700K. Explicit inclusion of the angle dependence of the emissivity of the structure (see the supporting information and Eq. S4) yields remarkably similar performance for the structure illustrated in **Figure 3**. This structure is predicted to retain 90% of its spectral selectivity over angles up to 80° (see **Figure S1**) and overall  $\eta_s$  and  $P$  of 62 % and 9.1 W/cm<sup>2</sup>, respectively at 1700K.

The experimental feasibility of each component in the Pareto optimal target structure was evaluated in turn. The volume fraction of W in Al<sub>2</sub>O<sub>3</sub> was tuned by cycle ratio in an atomic layer deposition (ALD) process and the thickness controlled by the total number of supercycles. The real and imaginary index of each layer was deduced from spectroscopic ellipsometry to be within 21 % of the modelled data for oxides and within 13 % for the W substrate. The largest deviation was for W grown by ALD (> 200%, see **Figure S2**), which is known to include a significant fraction of Si and F.<sup>32-33</sup> Furthermore, the real and imaginary index of the variable fraction alloy were found to be more accurately modeled by a Bruggeman approximation<sup>34</sup> than by Maxwell-Garnett theory (see discussion in the Supporting Information). As such, a second computational screening was undertaken that implements the experimentally realized materials properties of this study as inputs. The results, shown in **Figure S3**, suggest that good control of the optical constants in each layer is paramount to achieving the best figures-of-merit. In particular,  $\eta_s$  is most sensitive to increases in the imaginary part of the refractive index at  $\lambda_{bg} > 2254$  nm which increase  $P_{inc}$  and thereby reduce  $\eta_s$ .

Pareto optimal structure with BR + W ( $A_{BR} = 2$ ) and alloy + BR + W ( $A_{BR} = 1.5$ ) were chosen for experimental fabrication at operating temperatures > 1000K. After mild densification of the oxide layers, which results in a slight blue-shift of resonances, the reflectance of BR + W and

alloy + BR + W samples were observed to remain stable upon annealing at 1273K and 1073K for 2hr under an atmosphere of dry Ar (see SI for details).

The predicted emission spectra were recalculated with experimentally realized optical constants and thicknesses and compared to experimental emission spectra, **Figure 4**.



**Figure 4.** Theoretical and experimental normal thermal emission of W-only at 973K, BR + W at 1373K, and Alloy + BR + W at 1273 K. Red shaded region represent error range assuming that the actual temperature of the sample surface is within  $\pm 50$  °C of the nearby thermocouple.

Emission of bare polished W substrate at 973 K was measured to be larger than expected, likely due to surface oxidation and roughening as indicated by visual evidence of substrate discoloration and significant loss of specular reflection. Even after implementation of an additional water and oxygen scrubber in the inert gas feed, as well as high temperature carbon felt, the purity of the nominally inert atmosphere of the heating stage could not be sufficiently suppressed to avoid the oxidation of the readily oxidized W surface. In contrast to bare W, the alloy + BR + W and BR + W samples maintained the same color and mirror finish after the same emission measurements to even higher temperature. That the oxide layers of BR protect the W surface from oxidation relaxes the requirements on working atmosphere for stable operation, and provides significant temperature stability advantage over previous reports, which may further utilize dilute  $H_2$  flow.<sup>20</sup> As predicted, the emissions from BR + W and alloy + BR + W approach that of a blackbody for wavelength less than 2254 nm and are dramatically suppressed at longer wavelengths for the case of BR + W. In both cases, the measured useful power densities were slightly greater than predicted while the measured spectral efficiencies were lower. For BR + W,

the primary cause of the enhanced thermal emission in the mid IR range  $> 2000$  nm is a change of electron phonon collision frequency at high temperatures, which is not captured in the simulations, leading to higher emissivity and additional undesired emission in this range.<sup>28, 35-36</sup> The emission of alloy + BR + W for wavelength less than 2254 nm is significantly enhanced to that of W-only and very close to predictions. The alloy + BR + W even more strikingly enhances emission at  $\lambda_{bg} < 2254$  nm; however, the alloy also results in significant emission in  $\lambda_{bg} > 2254$  nm, which reverses any potential improvement in  $\eta_s$ . This discrepancy originates from an imaginary refractive index for ALD-grown W in the alloy that is significantly larger than literature values for pure, bulk W. The  $\eta_s$  and  $P$  of the oxidized W at 973 K is 15.6 % and 0.1 W/cm<sup>2</sup>, BR + W at 1373 K is 46.8 % and 2.4 W/cm<sup>2</sup>, and alloy + BR + W at 1273 K is 27.1 % and 1.9 W/cm<sup>2</sup>, respectively.

From the above analysis, the overall system efficiency for a thermophotovoltaic system that would implement these emitters may be estimated by using either an idealized, or previously benchmarked, InGaAsSb photovoltaic with parameterized values of open circuit voltage ( $V_{OC}$ ) and fill factor (FF) for a given short-circuit current density ( $J_{SC}$ ),<sup>37</sup> which is calculated by assuming room temperature operation of the cell and 80% external quantum efficiency (EQE).<sup>38</sup> That is,  $J_{SC}$  is simply  $P$  divided by the voltage corresponding to the useful photons threshold (0.55 V) which is further multiplied by a scalar in the case of the benchmarked device. **Table 2** summarizes the predicted thermophotovoltaic conversion efficiency of heat to electrical power,  $\eta_{TPV}$ , calculated as<sup>38</sup>

$$\eta_{TPV} = \frac{J_{SC} V_{OC} FF}{P_{inc}} \quad (5)$$

for (1) an ideal PV cell and the ideal Pareto optimal emitter calculated here, (2) an ideal PV cell and the emitter measured herein, and (3) a previously benchmarked PV cell<sup>37</sup> and the emitter measured herein. We assumed 100% EQE, 0.55 eV  $V_{OC}$ , and 81.6% FF for the ideal PV.<sup>39</sup> If the heat was provided by a perfect solar absorber then  $\eta_{TPV}$  is directly comparable to conventional photovoltaic efficiency. A significant reduction of overall system efficiency (60~70%) is predicted when experimental InGaAsSb PV parameters are used, consistent with literature reports,<sup>9, 29</sup> and points to the need for further improvement in small bandgap PV efficiency.

	Alloy/BR/W at 1273 K	BR/W at 1373 K	(Oxidized) W at 973 K	SiC at 1273 K
<b>Ideal PV + Theoretical Emitter</b>	52.5	49.1	25.3	18.4
<b>Ideal PV + Experimental Emitter</b>	22.1	38.2	12.8	
<b>Benchmarked PV + Ideal Emitter</b>	19.4	18.3	6.8	6.8
<b>Benchmarked PV + Experimental Emitter</b>	8.2	14.0	3.9	

**Table 2.** Thermophotovoltaic efficiency,  $\eta_{\text{TPV}}$  (%) projected for (1) an ideal InGaAsSb PV and an optimal theoretically-calculated emitter, (2) an ideal PV and the experimentally-measured emitter, and (3) a previously benchmarked PV cell and the experimentally-measured emitter.

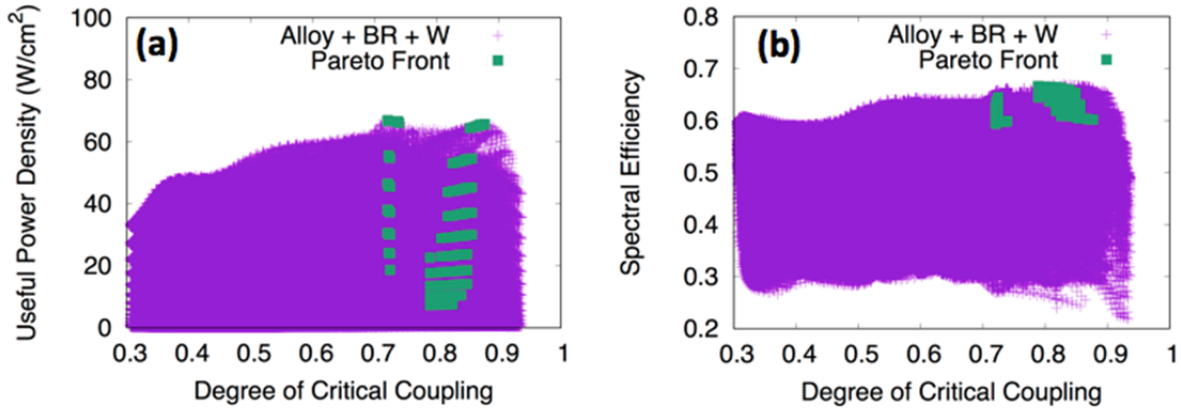
In the most conservative case (3), the  $\eta_{\text{TPV}}$  projected for our experimental BR + W emitter working at 1373K in a TPV system is 14.0 %. Note that the efficiency for the benchmarked PV is not equal in each case because FF and  $V_{\text{OC}}$  vary with  $J_{\text{SC}}$ .<sup>37</sup> The  $\eta_{\text{TPV}}$  with either BR + W or alloy + BR + W realized emitter is projected to be greater than that of the InGaAsSb PV alone under standard AM1.5 spectra ( $\sim 6.3\%$ ),<sup>3</sup> signifying that the TPV is improving solar conversion efficiency. However, a more ideal selective emitter or more ideal PV are required to exceed the efficiency of traditional single junction PV (28.8 %).<sup>40</sup> The calculated efficiency, projected from the experimentally realized emitter, is also slightly greater than that of the most efficient experimental system reported to date ( $\sim 10.2\%$ ).<sup>3</sup> The weak-absorber approach implemented herein is also simpler, as it does not include a cool-side selective optical filter on the PV, as in previous reports.<sup>3</sup> The enhanced  $\eta_{\text{TPV}}$  calculated from experimental emission herein originates largely from the spectral selectivity of the BR and the stabilization of selective emittance at high temperature. Projected  $\eta_{\text{TPV}}$  values may be further improved by 1) better leveraging the critical coupling approach through improvement of experimental material optical properties and 2)

increasing the stable operational temperature of the emitter through the use of more temperature-tolerant materials and combinations.

As a central hypothesis driving this overall structure design is the critical coupling of the Bragg reflector and thin-film alloy, we define a metric that quantifies the degree of critical coupling ( $D_{CC}$ ). The condition for critical coupling is that the absorption resonance frequency and bandwidth of the thin-film alloy layer should match the resonance frequency and bandwidth associated with the *stored energy* spectrum of the Bragg reflector,<sup>25</sup> which can be derived from the transfer matrix equations (see Supporting Information). A natural way to define the degree of critical coupling is therefore to compute the overlap of the absorption spectrum of the alloy ( $A_{Alloy}(\lambda)$ ) with the stored energy spectrum of the Bragg reflector ( $E_S(\lambda)$ ),

$$D_{CC} = \frac{\int_{\lambda_{min}}^{\lambda_{max}} A_{Alloy}(\lambda) E_S(\lambda) d\lambda}{\left( \int_{\lambda_{min}}^{\lambda_{max}} A_{Alloy}(\lambda) A_{Alloy}(\lambda) d\lambda \right)^{\frac{1}{2}} \left( \int_{\lambda_{min}}^{\lambda_{max}} E_S(\lambda) E_S(\lambda) d\lambda \right)^{\frac{1}{2}}} \quad (6)$$

That a high degree of critical coupling is characteristic of a Pareto optimal solution in this study can be seen in **Figure 5**. The optimal solutions all exhibit a relatively high degree of critical coupling with values near 0.7 and 0.9. However, interestingly, the highest degrees of critical coupling are not associated with simultaneously high  $\eta_s$  and  $P$  as seen by only non-optimal solutions with  $D_{CC} > 0.9$ .



**Figure 5.** Comparison of possible values for  $P$  and  $\eta_s$  plotted against degree of critical coupling for emitters at temperatures between 1200 K and 2200 K when  $\lambda_{BG} = 2254$  nm.

## Conclusions

We showed how ideas of Pareto optimality and critical coupling provide a clear path to significantly higher performing thermophotovoltaic emitters. We identify a route to tunable emission with exceptionally simple planar stacks based on less than six layers. This approach provides contrast to recent trends toward more complex nanostructured selective emitters, although it may not be incompatible with it. Experimental validation of one optimal solution results in a good match to the predicted selective emission structure after accounting for experimental non-idealities, most notably a weak absorber alloy layer with non-ideal optical properties. Additional development of more thermally stable oxides and more tunable and temperature stable weakly absorbing alloys are expected to further increase the experimentally achievable emitter figures-of-merit and, thereby, thermophotovoltaic system efficiency.

## Methods

### Computational Methods

The emissivity of the structure is equated to the absorbance (Kirchoff's law) and is calculated from

$$\epsilon(\lambda) = 1 - R(\lambda) - T(\lambda) \quad (7)$$

where  $R(\lambda)$  and  $T(\lambda)$  are the reflection and transmission of light at wavelength  $\lambda$  incident from the alloy side. Because of the 1D nature of the structures, these quantities can be calculated analytically by solving Fresnel's equations via the transfer matrix approach<sup>31</sup> (see Supporting Information). These calculations take as input the thickness and wavelength-dependent (and sometimes complex) refractive index of each layer, as well as the wavelength, polarization, and angle of incidence of light.

Our computational search for high performance emitter structures varies the following structural parameters: (1) the volume fraction of tungsten in the tungsten-alumina alloy ( $f_W$ ), (2) the number of dielectric pair layers (or periods) in the Bragg reflector ( $\Lambda_{BR}$ ), (3) the thickness of the low refractive index layer in the Bragg reflector ( $d_{low}$ ), (4) the thickness of the high refractive index layer in the Bragg reflector ( $d_{high}$ ). The materials that compose the Bragg reflector are chosen to be SiO<sub>2</sub> (low refractive index layer,  $n_{low} = 1.45$  in calculations leading to Figure 2 and 3) and TiO<sub>2</sub> (high refractive index layer,  $n_{high} = 2.1$  in calculations leading to Figure 2 and 3). The alloy layer and alumina spacer layer have their thicknesses fixed at 20 nm and 10 nm for all virtual screening calculations. Several thicker alloy layers were considered for comparison to

fabricated structures (e.g. 32 nm, as in Figure 4). We model the alloy layer using an effective medium theory, which maintains the isotropy of this layer in the  $x - y$  plane. In this approach, the alloy is considered to consist of uniformly distributed spherical inclusions of tungsten metal embedded in aluminum oxide, based on a previous report of W-Al<sub>2</sub>O<sub>3</sub> alloys prepared by ALD.<sup>23</sup> Maxwell Garnett theory and Bruggeman's approximation<sup>34, 41</sup> are employed to compute the wavelength-dependent refractive index of the alloy (see Supporting Information). In these models, one simply specifies the refractive index of the materials in the alloy along with their volume fractions to arrive at a single dielectric function for the alloy; further details on the refractive indices of the alloy components are described in the Supporting Information. We find that Bruggeman's approximation shows better agreement with alloys generated by ALD at low to moderate volume fractions of tungsten in alumina.

The preceding structural parameters are sufficient inputs to solve the Transfer Matrix Equations and compute the emissivity via Eq. (7). The emissivity can therefore be seen to be a function of these four variables, in addition to frequency:  $\epsilon(\omega, v_F, d_{low}, d_{high}, \Lambda_{BR})$ . From Eqs. (3) and (4), temperature and  $\lambda_{BG}$  are also important parameters for determining the ultimate figures of merit for the emitter. Consequently, we can see that the spectral efficiency and useful power density are functions of the structural parameters, the band gap, and the temperature. The search space of each parameter  $\lambda_{BG}$  is discretized into 18 equally spaced values. We search values of the volume fraction  $f_W$  between 0 and 0.85, values of  $d_{low}$  between 180 nm and 435 nm, values of  $d_{high}$  between 120 nm and 290 nm, values of  $\Lambda_{BR}$  between 0 and 8.5 (in units of 0.5), and values of  $T$  between 1200 and 2200 K. We consider  $\lambda_{BG}$  to be 2254 nm corresponding to InGaAsSb PV cells.

We apply a virtual screening approach based on identifying the set of Pareto optimal solutions with respect to the  $P$  and  $\eta_s$  figures-of-merit, where a Pareto optimal solution is one that is not dominated by any other solutions in the search space. For the bi-objective search considered in this work, a solution  $x_i$  is dominated by the solution  $x_j$  if  $\eta_s(x_j) \geq \eta_s(x_i)$  and  $P(x_j) \geq P(x_i)$ , along with  $\eta_s(x_j) > \eta_s(x_i)$  and/or  $P(x_j) > P(x_i)$ . Put in simpler terms, no solutions exist in the search space that simultaneously have higher  $\eta_s$  and  $P$  values than the Pareto optimal solutions. The set of Pareto optimal solutions is the Pareto front.

Once screened for Pareto optimality, structures can be further analyzed for practical features like ease of fabrication. For example, the Pareto front may contain some structures with a very high number of layers in the Bragg reflector, and others with a low number of layers. The structure with a low number of layers would be preferred.

383

## 384 **Experimental Methods**

385 Polished tungsten substrates ( $1\text{ cm}^2$ ) were sourced from MTI Corporation. The dielectric Bragg  
386 reflector was deposited by plasma enhanced atomic layer deposition in a commercial ALD  
387 system (Fiji, Cambridge NanoTech Inc.). Aluminum oxide ( $\text{Al}_2\text{O}_3$ ) and W were alloyed by ALD  
388 in a tube-style viscous flow reactor similar to those previously reported<sup>23</sup> with a processes  
389 adapted from literature.<sup>23</sup> The composition could be tuned over a wide range of values by tuning  
390 the ALD cycle ratio at constant temperature. Ex-situ annealing was performed in a high  
391 temperature tube furnace (MTI GSL-1700X) under 200 SCCM Ar flow using a bubbler filled  
392 with mineral oil. The Ar flow was further purified just prior to entering the furnace with an in-  
393 line inert gas scrubber (Entegris CE70KFI4R). Samples were further placed on top of a carbon  
394 felt pad, which acts as an oxygen getter at high temperature, in an alumina boat. Although  
395 samples with oxide Bragg reflectors are relatively insensitive to the purity of the inert gas  
396 atmosphere, bare polished W is exceedingly sensitive.

397 A Nicolet 6700 FTIR spectrometer with external beam port was used to spectrally resolve the  
398 thermal emission of samples heated in a controlled-atmosphere Linkam stage (TS1500). In order  
399 to determine the power density in absolute units ( $\text{W cm}^{-2}\text{ nm}^{-1}\text{ sr}^{-1}$ ) the spectrometer was  
400 calibrated with a SiC wafer with format similar to the W substrates. SiC exhibits a thermal  
401 emission spectrum with a stable and constant emissivity of  $\sim 0.8$  over nearly the entire range  
402 relevant wavelengths. SiC is also exceptionally resistant to oxidation at high temperatures unlike  
403 other commonly used greybody materials such as graphite. The transmittance of the SiC  
404 substrate (0.33 mm thickness and one-side polished 4H SiC, MTI corporation) was 3.5 % at 1  
405  $\mu\text{m}$  and decreased rapidly to  $\sim 0\%$  for longer wavelengths (see **Figure S7**) eliminating the  
406 possibility of significant contribution from the underlying  $\text{Al}_2\text{O}_3$  heater cup. The 7 mm diameter  
407 and 3 mm deep sample cup was resistively heated by a nearby Pt coil at a rate of  $100\text{ }^\circ\text{C/min}$   
408 under Ar supply of 60 SCCM. In order to limit the contribution of thermal emission from the  
409 heating cup walls (not covered by the substrate) as well as limit the emission angle of acceptance,  
410 a 1/8 inch diameter aperture was fixed above the heating stage. The sample emission was  
411 reflected by a  $90^\circ$  off-axis paraboloid, before being directed to the external beam port of the  
412 FTIR. A sapphire window and  $\text{CaF}_2$  windows were used for the heating stage and the external  
413 beam port of FTIR spectrometer, respectively.

414 Reflectance spectra of samples were measured via UV-vis-NIR spectrophotometer (Cary 5000)  
415 and Nicolet 6700 FTIR with integrating sphere (Mid-IR IntegratIR™).

416



## 417 ASSOCIATED CONTENT

### 418 **Supporting Information.**

419 Detailed derivation of all calculated values, target and actual emitter parameters, target and  
420 actual optical constants, and reflectance spectra are available free of charge.

421

## 422 AUTHOR INFORMATION

### 423 **Corresponding Authors**

424 \*Jonathan J. Foley IV ([foleyj10@wpunj.edu](mailto:foleyj10@wpunj.edu))

425 \*Alex B. F. Martinson ([martinson@anl.gov](mailto:martinson@anl.gov))

### 426 **Author Contributions**

427 SKG, ABFM, and JJF conceived of the project. JJF implemented and executed the virtual  
428 screening methodology; validation and preliminary calculations were performed by JJF and JH.  
429 SKG, ABFM, NJ, and JJF analyzed all computational results. Fabrication and characterization  
430 of emitter structures was performed by NJ and ABFM. The manuscript was written by NJ, SKG,  
431 ABFM, and JJF. All authors have given approval to the final version of the manuscript.

## 432 ACKNOWLEDGMENT

433 This work was performed, in part, at the Center for Nanoscale Materials, a U.S. Department of  
434 Energy Office of Science User Facility, and supported by the U.S. Department of Energy, Office  
435 of Science, under Contract No. DE-AC02-06CH11357. This material is, in part, based upon  
436 work supported by Laboratory Directed Research and Development (LDRD) funding from  
437 Argonne National Laboratory, provided by the Director, Office of Science, of the U.S.

Department of Energy under Contract No. DEAC02-06CH11357. The authors thank Jeff Elam and Anil Mane for use of the infrared-reflective integrating sphere and for useful conversations regarding the ALD of  $\text{Al}_2\text{O}_3/\text{W}$  alloys. The authors also thank Richard Schaller, Vitali Prakapenka, and Yang Ren for useful conversations and use of components for measurement of emission at high temperature. JH Acknowledges the Union County College Bridges to Baccalaureate Program for financial support. JJF Acknowledges the Center for Research at William Paterson University for financial support.

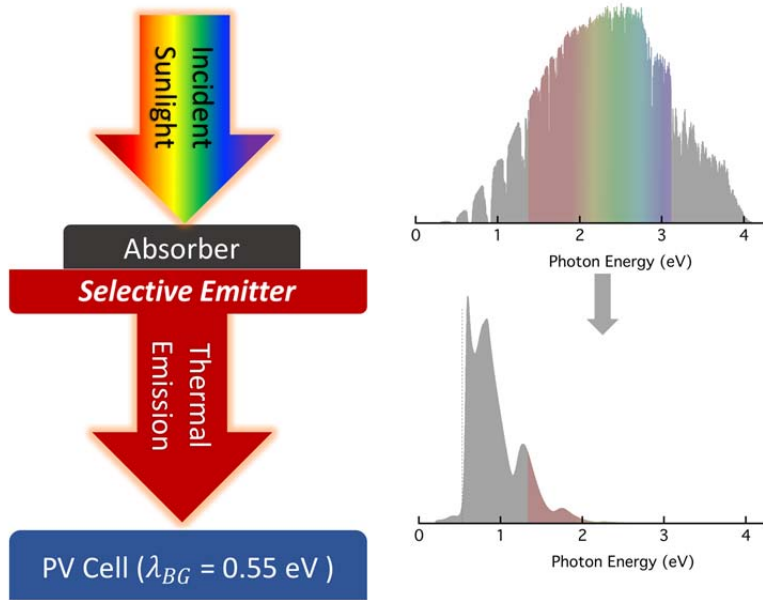
## REFERENCES

- Shockley, W.; Queisser, H. J., Detailed Balance Limit of Efficiency of p-n Junction Solar Cells. *Journal of Applied Physics* **1961**, 32 (3), 510-519.
- Song, M.; Yu, H.; Hu, C.; Pu, M.; Zhang, Z.; Luo, J.; Luo, X., Conversion of broadband energy to narrowband emission through double-sided metamaterials. *Opt. Express* **2013**, 21 (26), 32207-32216.
- Bierman, D. M.; Lenert, A.; Chan, W. R.; Bhatia, B.; Celanović, I.; Soljačić, M.; Wang, E. N., Enhanced photovoltaic energy conversion using thermally based spectral shaping. *Nature Energy* **2016**, 1, 16068.
- Datas, A.; Chubb, D. L.; Veeraragavan, A., Steady state analysis of a storage integrated solar thermophotovoltaic (SISTPV) system. *Solar Energy* **2013**, 96, 33-45.
- St-Gelais, R.; Zhu, L.; Fan, S.; Lipson, M., Near-field radiative heat transfer between parallel structures in the deep subwavelength regime. *Nat Nano* **2016**, 11 (6), 515-519.
- Zhou, Z.; Sakr, E.; Sun, Y.; Bermel, P., Solar thermophotovoltaics: reshaping the solar spectrum. *Nanophotonics* **2016**, 5 (1), 1.
- Badescu, V., Upper bounds for solar thermophotovoltaic efficiency. *Renewable Energy* **2005**, 30 (2), 211-225.
- Inoue, T.; De Zoysa, M.; Asano, T.; Noda, S., Realization of narrowband thermal emission with optical nanostructures. *Optica* **2015**, 2 (1), 27-35.
- Ungaro, C.; Gray, S. K.; Gupta, M. C., Solar thermophotovoltaic system using nanostructures. *Opt. Express* **2015**, 23 (19), A1149-A1156.
- Lenert, A.; Bierman, D. M.; Nam, Y.; Chan, W. R.; Celanovic, I.; Soljagic, M.; Wang, E. N., A nanophotonic solar thermophotovoltaic device. *Nat Nano* **2014**, 9 (2), 126-130.
- Rinnerbauer, V.; Lenert, A.; Bierman, D. M.; Yeng, Y. X.; Chan, W. R.; Geil, R. D.; Senkevich, J. J.; Joannopoulos, J. D.; Wang, E. N.; Soljačić, M.; Celanovic, I., Metallic Photonic Crystal Absorber-Emitter for Efficient Spectral Control in High-Temperature Solar Thermophotovoltaics. *Advanced Energy Materials* **2014**, 4 (12), 1400334-n/a.
- Ye, H.; Wang, H.; Cai, Q., Two-dimensional VO<sub>2</sub> photonic crystal selective emitter. *Journal of Quantitative Spectroscopy and Radiative Transfer* **2015**, 158, 119-126.

13. Rybicki, G. B.; Lightman, A. P., *Radiative Processes in Astrophysics*. Wiley: 2008.
14. Foley, J. J.; Ungaro, C.; Sun, K.; Gupta, M. C.; Gray, S. K., Design of emitter structures based on resonant perfect absorption for thermophotovoltaic applications. *Opt. Express* **2015**, *23* (24), A1373-A1387.
15. Mayer, A.; Gaouyat, L.; Nicolay, D.; Carletti, T.; Deparis, O., Multi-objective genetic algorithm for the optimization of a flat-plate solar thermal collector. *Opt. Express* **2014**, *22* (S6), A1641-A1649.
16. Gomez-Bombarelli, R.; Aguilera-Iparraguirre, J.; Hirzel, T. D.; Duvenaud, D.; Maclaurin, D.; Blood-Forsythe, M. A.; Chae, H. S.; Einzinger, M.; Ha, D.-G.; Wu, T.; Markopoulos, G.; Jeon, S.; Kang, H.; Miyazaki, H.; Numata, M.; Kim, S.; Huang, W.; Hong, S. I.; Baldo, M.; Adams, R. P.; Aspuru-Guzik, A., Design of efficient molecular organic light-emitting diodes by a high-throughput virtual screening and experimental approach. *Nat Mater* **2016**, *15* (10), 1120-1127.
17. Haupt, R. L.; Werner, D. H., *Genetic Algorithms in Electromagnetics*. Wiley: 2007.
18. Ghosh, A.; Tsutsui, S., *Advances in Evolutionary Computing: Theory and Applications*. Springer Berlin Heidelberg: 2012.
19. In some cases, the  $\eta_s$  in Table 1 differs from that reported in the associated publication due to the different way in which spectral efficiency may be calculated, sometimes without the penalty for photons with energy greater than the bandgap.
20. Yeng, Y. X.; Ghebrebrhan, M.; Bermel, P.; Chan, W. R.; Joannopoulos, J. D.; Soljačić, M.; Celanovic, I., Enabling high-temperature nanophotonics for energy applications. *Proceedings of the National Academy of Sciences* **2012**, *109* (7), 2280-2285.
21. Rinnerbauer, V.; Yeng, Y. X.; Chan, W. R.; Senkevich, J. J.; Joannopoulos, J. D.; Soljačić, M.; Celanovic, I., High-temperature stability and selective thermal emission of polycrystalline tantalum photonic crystals. *Opt. Express* **2013**, *21* (9), 11482-11491.
22. Zhou, X.; Jankowska, J.; Li, L.; Giri, A.; Hopkins, P. E.; Prezhdo, O. V., Strong Influence of Ti Adhesion Layer on Electron-Phonon Relaxation in Thin Gold Films: Ab Initio Nonadiabatic Molecular Dynamics. *ACS Applied Materials & Interfaces* **2017**, *9* (49), 43343-43351.
23. Mane, A. U.; Elam, J. W., Atomic Layer Deposition of W:Al<sub>2</sub>O<sub>3</sub> Nanocomposite Films with Tunable Resistivity. *Chemical Vapor Deposition* **2013**, *19* (4-6), 186-193.
24. Piper, J. R.; Liu, V.; Fan, S., Total absorption by degenerate critical coupling. *Applied Physics Letters* **2014**, *104* (25), 251110.
25. Piper, J. R.; Fan, S., Total Absorption in a Graphene Monolayer in the Optical Regime by Critical Coupling with a Photonic Crystal Guided Resonance. *ACS Photonics* **2014**, *1* (4), 347-353.
26. Tischler, J. R.; Bradley, M. S.; Bulović, V., Critically coupled resonators in vertical geometry using a planar mirror and a 5 nm thick absorbing film. *Opt. Lett.* **2006**, *31* (13), 2045-2047.
27. Ungaro, C.; Gray, S. K.; Gupta, M. C., Graded-index structures for high-efficiency solar thermophotovoltaic emitting surfaces. *Opt. Lett.* **2014**, *39* (18), 5259-5262.
28. Dyachenko, P. N.; Molesky, S.; Petrov, A. Y.; Störmer, M.; Krekeler, T.; Lang, S.; Ritter, M.; Jacob, Z.; Eich, M., Controlling thermal emission with refractory epsilon-near-zero metamaterials via topological transitions. *Nature Communications* **2016**, *7*, 11809.

29. Garín, M.; Hernández, D.; Trifonov, T.; Alcubilla, R., Three-dimensional metallo-dielectric selective thermal emitters with high-temperature stability for thermophotovoltaic applications. *Solar Energy Materials and Solar Cells* **2015**, *134*, 22-28.
30. Akselrod, G. M.; Walker, B. J.; Tisdale, W. A.; Bawendi, M. G.; Bulovic, V., Twenty-Fold Enhancement of Molecular Fluorescence by Coupling to a J-Aggregate Critically Coupled Resonator. *ACS Nano* **2012**, *6* (1), 467-471.
31. Yeh, P., *Optical Waves in Layered Media*. Wiley: 2005.
32. Fabreguette, F. H.; Sechrist, Z. A.; Elam, J. W.; George, S. M., Quartz crystal microbalance study of tungsten atomic layer deposition using WF<sub>6</sub> and Si<sub>2</sub>H<sub>6</sub>. *Thin Solid Films* **2005**, *488* (1), 103-110.
33. Kima, S.-H.; Kwaka, N.; Kima, J.; Sohn, H., A Comparative Study of the Atomic-Layer-Deposited Tungsten Thin Films as Nucleation Layers for W-Plug Deposition. *J. Electrochem. Soc.* **2006**, *153* (10), G887-G893.
34. Zhuromskyy, O., *Applicability of Effective Medium Approximations to Modelling of Mesocrystal Optical Properties*. 2016; Vol. 7, p 1.
35. Ujihara, K., Reflectivity of Metals at High Temperatures. *Journal of Applied Physics* **1972**, *43* (5), 2376-2383.
36. Winsemius, P.; Kampen, F. F. v.; Lengkeek, H. P.; Went, C. G. v., Temperature dependence of the optical properties of Au, Ag and Cu. *Journal of Physics F: Metal Physics* **1976**, *6* (8), 1583.
37. Chan, W.; Huang, R.; Wang, C.; Kassakian, J.; Joannopoulos, J.; Celanovic, I., Modeling low-bandgap thermophotovoltaic diodes for high-efficiency portable power generators. *Solar Energy Materials and Solar Cells* **2010**, *94* (3), 509-514.
38. Qiu, K.; Hayden, A. C. S.; Mauk, M. G.; Sulima, O. V., Generation of electricity using InGaAsSb and GaSb TPV cells in combustion-driven radiant sources. *Solar Energy Materials and Solar Cells* **2006**, *90* (1), 68-81.
39. Green, M. A., Solar cell fill factors: General graph and empirical expressions. *Solid-state electronics* *24* (8), 788-789.
40. Green, M. A.; Emery, K.; Hishikawa, Y.; Warta, W.; Dunlop, E. D., Solar cell efficiency tables (version 48). *Progress in Photovoltaics: Research and Applications* **2016**, *24* (7), 905-913.
41. Bohren, C. F.; Clothiaux, E. E.; Huffman, D. R., *Absorption and Scattering of Light by Small Particles*. Wiley-VCH: 2009.

## TOC Graphic



554

555